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**RESPONSE AFTER FINAL  
EXPEDITED PROCEDURE REQUESTED  
EXAMINING GROUP ART UNIT 2857  
PATENT**

Customer No. 22,852  
Attorney Docket No. 07553.0024-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kazushi TAHARA et al.

Application No.: 10/648,341

Filed: August 27, 2003

For: PART MAINTENANCE SYSTEM  
AND PART MAINTENANCE  
METHOD OF SEMICONDUCTOR  
PROCESSING SYSTEM

)  
) Group Art Unit: 2857  
)  
) Examiner: Jeffrey R. West  
)  
) Confirmation No.: 3400  
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w/ RCE  
5/23/06*

**Mail Stop: AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT AFTER FINAL**

In reply to the Final Office Action mailed January 23, 2006, and pursuant to 37 C.F.R. § 1.116, Applicants propose amending the above-identified application as follows:

Please amend the claims and the drawings as indicated in the Amendments to the Claims and the Amendments to the Drawings sections below.

The **Amendments to the Claims** section begins on page 3 of this Amendment After Final.

The **Amendments to the Drawings** section begins on page 14 of this Amendment After Final. The amendments to the drawings are indicated in red ink on